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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Lu et al.

Art Unit:

2826

Serial No.:

10/722,013

Examiner:

Erdem, F.

Filing Date:

11/25/2003

Docket No.:

TI-35669

Customer No.:

23494

Conf. No.:

6979

Title: A CAPACITOR FORMED ON A RECRYSTALLIZED POLYSILICON LAYER

AND A METHOD OF MANUFACTURE THEREFOR

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on the date shown below:

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April 3, 2006

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NAME OF INVENTOR(S):		RECEIPT DATE & SERIAL NO.:
Lu		Serial No.: 10/722,013 Filing Date: 11/25/2003
TITLE OF INVENTION:		
A CAPACITOR FORMED		Conf. No.: 6979
TI FILE NO.:	DEPOSIT ACCT. NO.:	1
TI-35669	20-0668	
FAXED: 4/3/2006		
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